

FEB 16 2006

PATENT

Atty. Dkt. No. APPM005191.C1/ISM/CORE/MCVD/PJS
Serial No.: 10/792,323

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Lawrence C. Lei

Serial No.: 10/792,323

Confirmation No.: 4370

Filed: March 3, 2004

For: Apparatus and Method for
Vaporizing Solid Precursor
for CVD or Atomic Layer
Deposition

Group Art Unit: 3742

Examiner: Sang Yeop Paik

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF FACSIMILE
TRANSMISSION UNDER 37 CFR 1.8

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number 571-273-8300 to the attention of the named Examiner, on the date below.

2/16/06
Date[Signature]
Signature

RESPONSE TO FINAL OFFICE ACTION DATED DECEMBER 16, 2005

In response to the Final Office Action dated December 16, 2005, having a shortened statutory period for response set to expire on March 16, 2006, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/005191.C1/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks begin on page 5 of this paper.